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Bib Data Sheet

CONFIRMATION NO. 8915

<b>SERIAL NUMBER</b> 09/942,213	<b>FILING DATE</b> 08/30/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 501.40475X00
<b>APPLICANTS</b> Maki Tanaka, Yokohama, JAPAN; Masahiro Watanabe, Yokohama, JAPAN; Kenji Watanabe, Oume, JAPAN; Mari Nozoe, Hino, JAPAN; Hiroshi Miyai, Hitachi, JAPAN;				
<b>** CONTINUING DATA *****</b> none JS				
<b>** FOREIGN APPLICATIONS *****</b> JS JAPAN 2001-185773 06/20/2001				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 10/08/2001</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>John Strong</i> Acknowledged <i>Examiner's Signature</i> Initials JS		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 19	<b>TOTAL CLAIMS</b> 18
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> 020457				
<b>TITLE</b> Method and apparatus for inspecting a semiconductor device				
<b>FILING FEE RECEIVED</b> 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	